EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	1	10/563519	US-PGPUB; USPAT	OR	ON	2007/11/08 05:33
S2	4	("20020066535"|"20030079550"|"5415585"|"5433238").PN.	US-PGPUB; USPAT	OR	ON	2007/11/07 17:12
S3	1	("6631334").PN.	US-PGPUB; USPAT	OR	OFF	2007/11/07 11:02
S4	3	(("5,758,680") or ("6,142,163") or ("6,316,045")).PN.	US-PGPUB; USPAT	OR	OFF	2007/11/07 11:44
S5	42	SNEH near OFER.in.	US-PGPUB; USPAT	OR	ON	2007/11/07 11:45
S6	3	("5187344"|"5191184"|"5453125").PN.	US-PGPUB; USPAT	OR	ON	2007/11/07 17:22
S8	230	third adj3 (FRE or (flow adj restrict$3 adj element))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 05:55
S10	4	S8 and (wafer or substrate)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:30
S11	1	S8 and (semiconductor adj (processing or production or manufacturing or treatment))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:33
S12	42	abatement adj chamber	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/07 19:05
S13	379	(156/345.29).CCLS.	US-PGPUB; USPAT	OR	OFF	2007/11/07 19:06

S14	687	((flow adj restrict$3 adj element))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/09 07:28
S15	91	S14 and (wafer or substrate)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 05:56
S16	15	S15 and (semiconductor adj (processing or production or manufacturing or treatment))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 05:56
S17	25	(adjustable or variable) adj3 (flow adj restrict$3 adj element)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:28
S18	3832	macronix.as.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:12
S19	740178	exhaust	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:12
S20	25	S18 and S19	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:12

S21	213	second adj3 ((pressure adj control adj chamber) or PCC)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:32
S22	13	S21 and (wafer or substrate)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:34
S23	149	second adj3 ((pressure adj control adj chamber))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:32
S24	2	S23 and (wafer or substrate)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 07:34
S25	46	("0187084"|"20020007790"|"20020076508"|"20020076508"|"20020187084"|"20030168001"|"20030180458"|"20040187779"|"20040187780"|"20040200412"|"4058430"|"4389973"|"4413022"|"4809950"|"4854263"|"4960488"|"4993357"|"5114683"|"5225366"|"5281274"|"5356476"|"5483919"|"5582866"|"5685914"|"5711811"|"5758680"|"5834371"|"5849092"|"5855680"|"5904800"|"5914278"|"5919332"|"5928426"|"6015590"|"6056824"|"6063198"|"6174377"|"6174377"|"6223684"|"6305314"|"6361607"|"6432256"|"6447607"|"6506352"|"6527911"|"6544341"|"6761796"|"0076508").PN.	US-PGPUB; USPAT	OR	ON	2007/11/09 06:25

S26	687	((flow adj restrict$3 adj element))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/09 07:28
S27	126	S26 and exhaust	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/09 07:28
S28	42	Sneh near Ofer .in.	US-PGPUB; USPAT	OR	ON	2007/11/15 08:15